

IFW AF/1752



I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: June 8, 2004

Signature: \_\_\_\_\_

(Michael K. Hull)

Docket No.: 30205/38088  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Geun Su Lee, et al.

Application No.: 10/080,319

Art Unit: 1752

Filed: February 21, 2002

Examiner: Yvette C. Thornton

For: PHOTORESIST MONOMERS, POLYMERS  
THEREOF AND PHOTORESIST  
COMPOSITION CONTAINING THE SAME

**AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION**

MS Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Commissioner:

**INTRODUCTORY COMMENTS**

Please enter the following amendment in response to the final office action mailed on April 8, 2004.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.